CERTIFICATE OF MAILING 37 C.F.R. §1.8

I hereby certify that this paper is being deposited with the U.S. Postal Service as First-Class Mail, postage prepaid, in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on the date shown below:

Date	Susan	F.	Maho

GAU:

Docket No.

8733.6641

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Woo Sup SHIN, et al.

SERIAL NO: 09/039,438

FILING DATE: March 16, 1998

FOR:

Etching Apparatus

AMENDMENT

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

SIR:



1763

EXAMINER: A. Powell

In response to the Office Action dated July 20, 1999, the time for response being extended to January 20, 2000 by the enclosed Petition and appropriate fee, please amend the above-referenced application as follows:

IN THE SPECIFICATION:

Please AMEND the specification as follows:

Page 2, line 3, delete "______" and insert therefor --09/002,037---

IN THE CLAIMS:

Please amend claims 1, 2, 5, 9-11 and 13-15 and add new claims 19 and 20 as follows:

1. (Amended) An etching apparatus for etching a glass substrate comprising:

a first tank including a first etchant;